

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of:

Ji-soo Kim et al.

Group Art Unit: Not Assigned

Serial No.: (TBD)

Examiner: Not Assigned

Filed: 30 September 2003

For: METHOD OF DETERMINING DEGREE OF CHARGE-UP INDUCED BY  
PLASMA USED FOR MANUFACTURING SEMICONDUCTOR DEVICE  
AND APPARATUS THEREFOR

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**PRELIMINARY AMENDMENT**

U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window, **Mail Stop Patent Application**  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

Preliminary to the examination of the above-identified application, please enter  
the following amendments and remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks begin on page 6 of this paper.